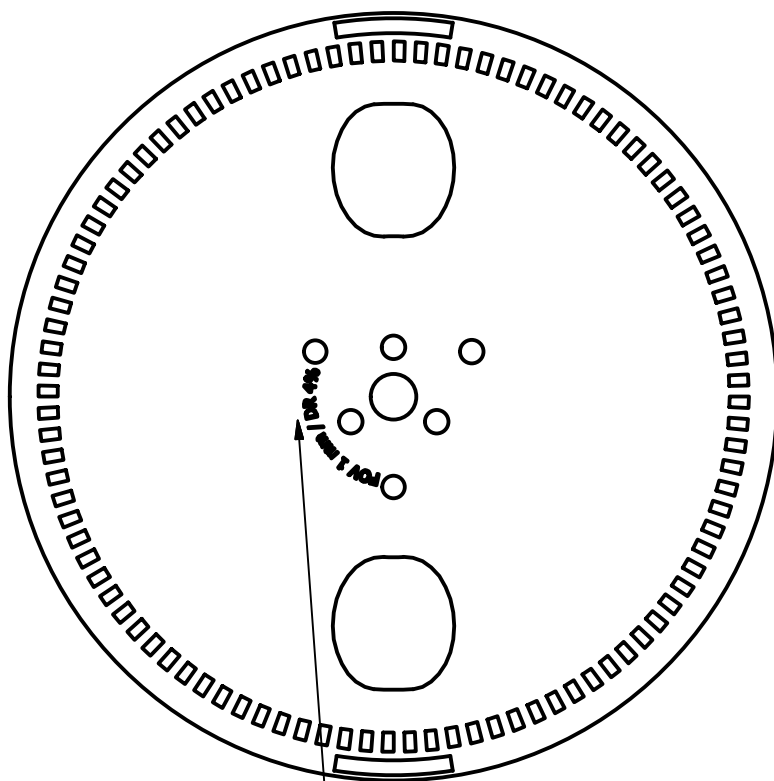




Reflective surface on top - caption should be readable, not mirrored.
Caption can be a poor quality (no tolerances) just to identify the piece.

DRAWN Radek Chrapkiewicz	ADDRESS STANFORD UNIVERSITY Schnitzer Lab 1050B Arastradero Rd #247 Palo Alto, CA 94304	
CREATED 11/16/2016		
TEL. (650)-798-7327	PART NAME custom chopper disk FOV 1 mm DR 4	
E-MAIL radekch@stanford.edu	MATERIAL Silicon wafer	UNITS MILIMITERS